

09/08/2008

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.	:	10/623,866	Confirmation No. :	6399
First Named Inventor	:	Yoshihiro KATO		
Filed	:	July 22, 2003		
TC/A.U.	:	1763		
Examiner	:	J. Lund		
Docket No.	:	101246.52582US		
Customer No.	:	23911		
Title	:	Plasma Process System and Plasma Process Method		

**SUPPLEMENTAL AMENDMENT AND RESPONSE**

**Mail Stop AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to a telephone conversation with the Examiner and supplemental to the Amendment and Response under 37 C.F.R. § 1.116 filed June 17, 2008, Applicant submits herewith the following Supplemental Amendment and Response.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this Response.

**Remarks** begin on page 7 of this Response.